

# ***The Nonlinear Optical Properties of Semiconductors***

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# Optical Susceptibility Tensor

$$\mathbf{P} = \varepsilon_0 \left[ \chi^{(1)} \mathbf{E} + \chi^{(2)} \mathbf{E}\mathbf{E} + \chi^{(3)} \mathbf{E}\mathbf{E}\mathbf{E} + \dots \right]$$

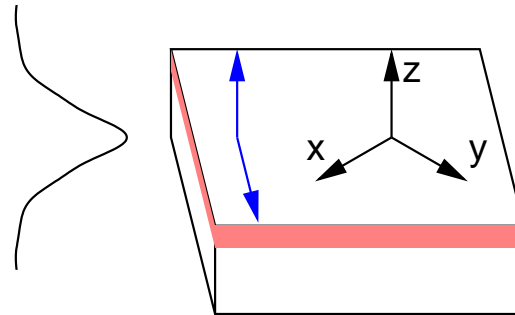
$\chi_{ij}^{(1)}$	$\omega$	Linear refraction and absorption
$\chi_{ijk}^{(2)}$	$\omega_1 + \omega_2$	Sum frequency generation
	$\omega_1 - \omega_2$	Difference frequency generation, rectification
	$\omega + 0$	Electro-optic (Pockel's) effect
$\chi_{ijkl}^{(3)}$	$\omega + \omega + \omega$	Third harmonic generation
	$\omega - \omega + \omega$	Nonlinear refraction and absorption, 4WM
	$\omega + 0 + 0$	Kerr electro-optic effect (DC)

# Contents

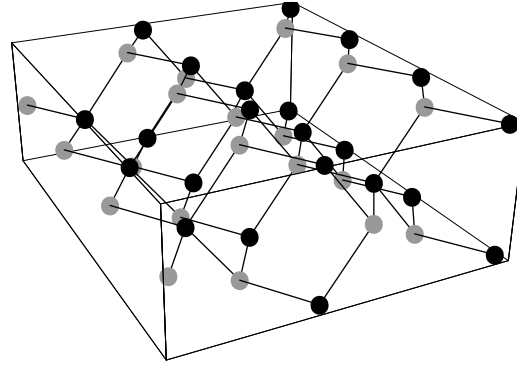
- Structure of zincblende semiconductors
- $\chi^{(1)}$ : Absorption & Refraction
- $\chi^{(2)}$ : Electro-optic effect (Pockels) & Frequency conversion, e.g. SHG
- $\chi^{(3)}$ : Two-photon Absorption, Nonlinear Refraction & 4 wave mixing
- Quasi- $\chi^{(3)}$ : Carrier effects, Electro-optic effect (Kerr) & Thermal effects

# Waveguide geometry

- Slab or rib waveguides
- Assume weakly guiding
- Also assume nonlinearity weak such that transverse guided mode unchanged
- Conventional orientation with  $[001]$  growth and  $[110]$  cleavage:



# Crystal Symmetries



- Common compound semiconductors in photonics have a zinc-blende (cubic) structure  $\bar{4}3m$
- Note different layer ordering for  $111$  and  $\bar{1}\bar{1}\bar{1}$
- Introducing heterostructure, e.g. quantum well, breaks translational invariance in one direction

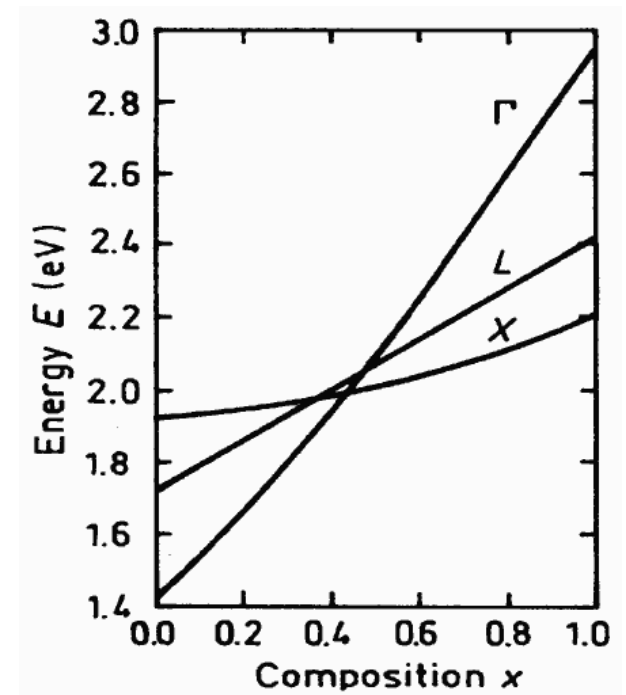
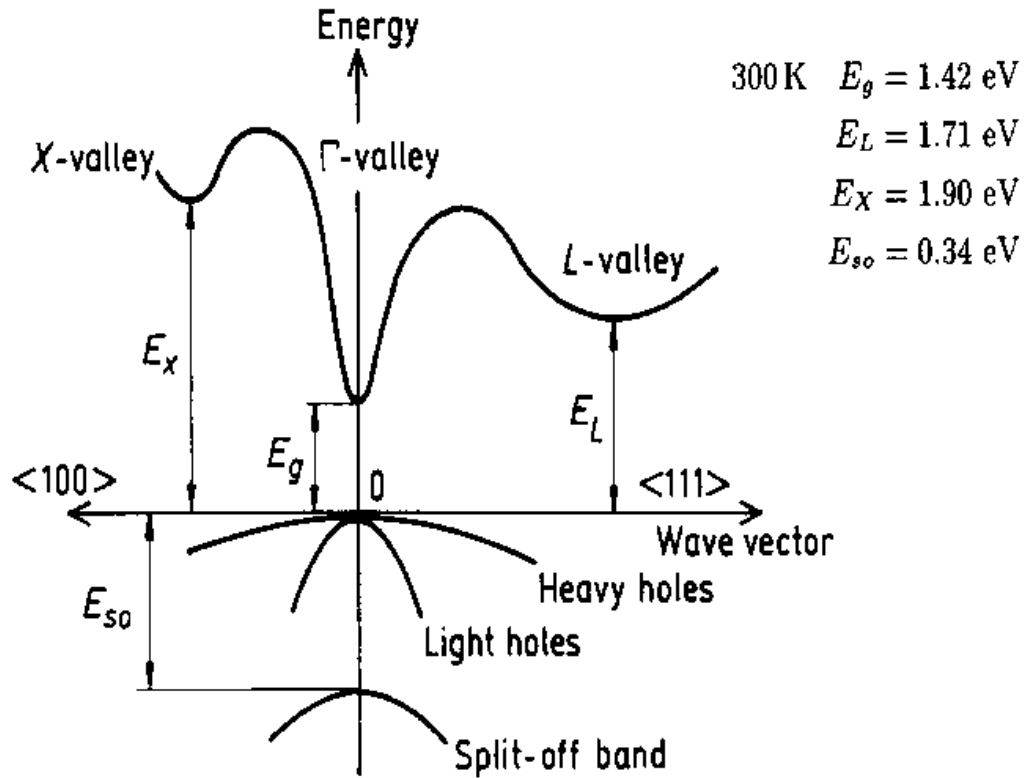
# Bandstructure models

- Bloch form for wavefunction with periodic  $u_{\mathbf{k}}(\mathbf{r})$

$$\psi(\mathbf{r}) = u_{\mathbf{k}}(\mathbf{r})e^{i\mathbf{k}\cdot\mathbf{r}}$$

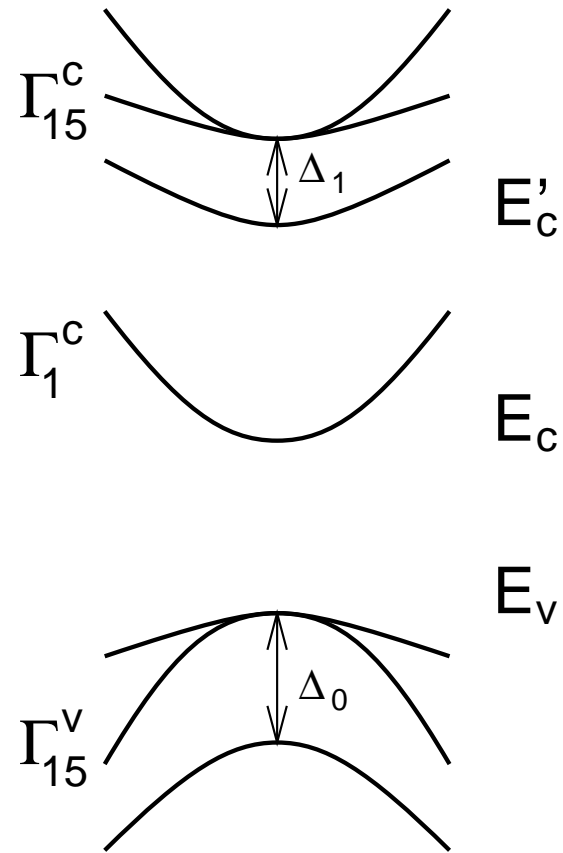
- Hamiltonian contains  $\mathbf{k} \cdot \mathbf{p}$  term — treat as perturbation
  - 2 parabolic bands: scalar model
  - Kane model with singlet conduction band and triplet valence band: vector but isotropic
  - Kane plus next highest conduction triplet: anisotropic

# AlGaAs bandstructure



$\text{Al}_x\text{Ga}_{1-x}\text{As}$  direct bandgap for  $x < 0.45$

# $k \cdot p$ models





# Quantum Theory of $\chi^{(n)}$

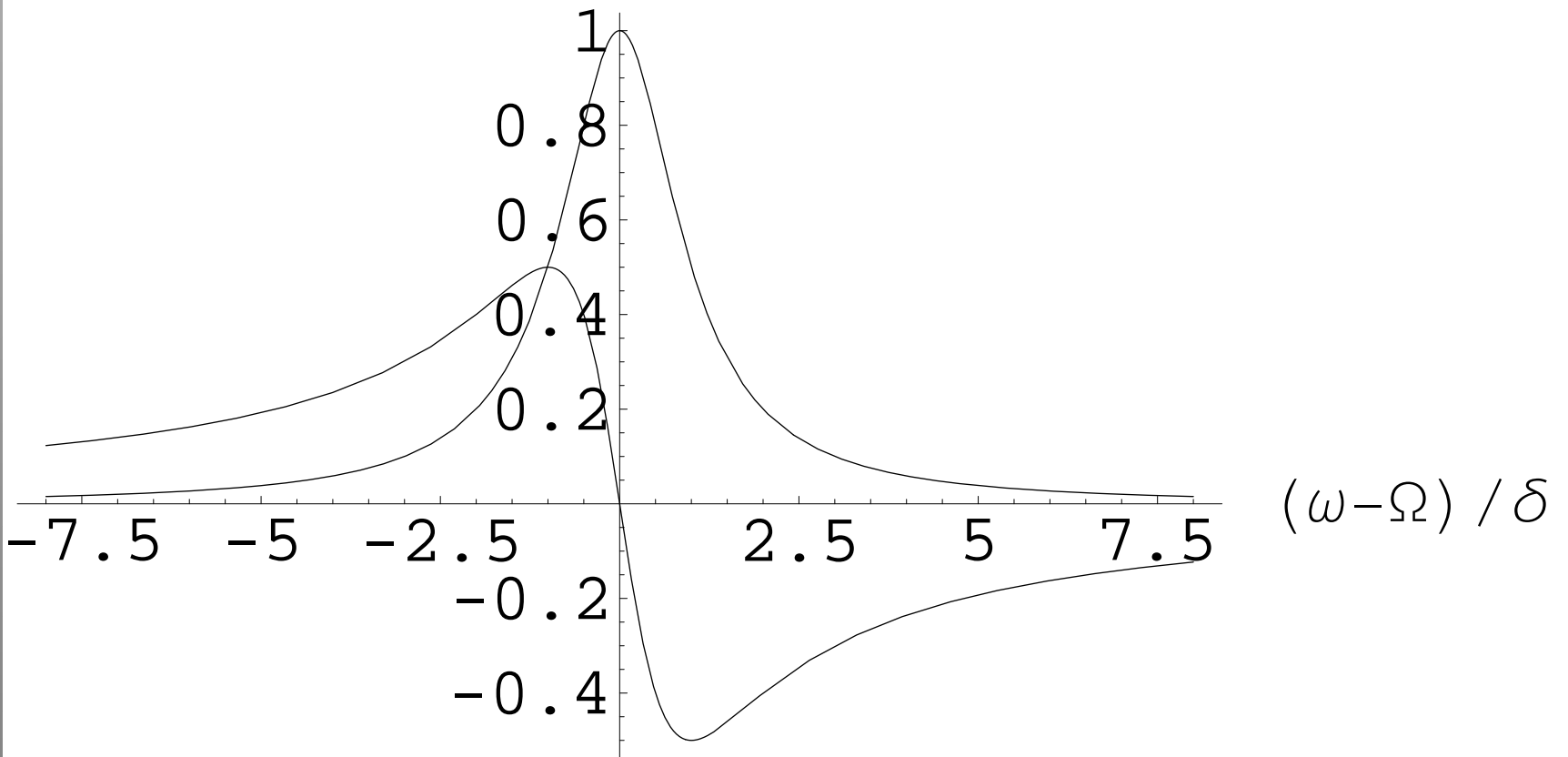
- Susceptibility expressions are derived using the quantum Liouville equation, with Hamiltonian  $H = H_0 + (e/m_0)\mathbf{A} \cdot \mathbf{p}$ .
- For  $\chi^{(n)}$  use sets of  $(n + 1)$ -level systems and sum over  $(n + 1)!$  time orderings.
- Evaluation of  $\chi^{(n)}$  in semiconductors requires:
  - Electronic energies (valence and conduction bands)
  - Momentum matrix elements between electronic states
  - Summation over *all* states

# Linear absorption and refraction

$$\chi_{ii}^{(1)}(\omega) = \frac{e^2}{2m_0^2 \hbar \omega^2} \sum_{\mathbf{k}, \text{bands}} |\mathbf{e}_i \cdot \mathbf{p}_{vc}(\mathbf{k})|^2 \times \left( \frac{1}{\Omega_{vc}(\mathbf{k}) - (\omega + i\delta)} + \frac{1}{\Omega_{vc}(\mathbf{k}) + (\omega + i\delta)} \right)$$

- take limit  $\delta \rightarrow 0$ :
  - $\alpha \propto \text{Im}\chi^{(1)}$  &  $n \propto \text{Re}\chi^{(1)}$
- matrix element  $|\mathbf{p}_{vc}(\mathbf{k})|$  is approximately constant.
- for parabolic bands, absorption follows square-root density-of-states

# $\chi^{(1)}$ for 2-level system



# Linear refraction

Dispersion with parabolic bands gives Adachi formula

$$\varepsilon(\omega) = A \left\{ f(X) + \frac{1}{2} \left[ \frac{E_g}{E_g + \Delta} \right]^{3/2} f(X_{so}) \right\} + B$$

$$f(X) = \text{Re}(2 - \sqrt{1 + X} - \sqrt{1 - X}) / X^2$$

$$n = \sqrt{\varepsilon}$$

$$X = \frac{\hbar\omega}{E_g} = \frac{\lambda_g}{\lambda}$$

$$X_{so} = \frac{\hbar\omega}{E_g + \Delta}$$

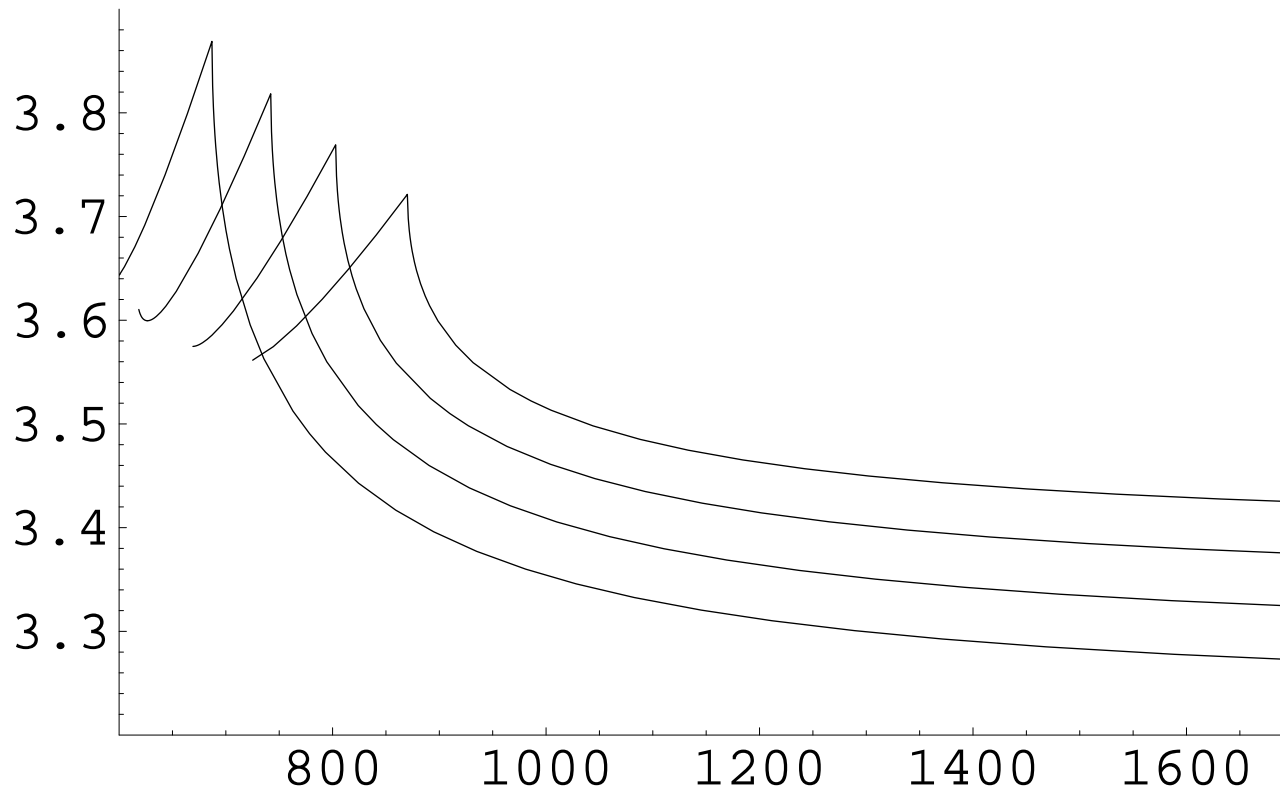
$$A(x) = 6.3 + 19.0x$$

$$B(x) = 9.4 - 10.2x$$

$$E_g = (1.425 + 1.155x + 0.37x^2) \text{ eV}$$

$$\Delta = 0.34 \text{ eV}$$

# Linear refraction (300K)



Refractive index vs wavelength (nm)

$x = 0, 0.1, 0.2, 0.3$

# Slowly varying envelope approx.

- Combine Maxwell's equations  $\rightarrow$  wave equation
- Fourier transform:  $t \rightarrow \omega$
- Substitute, with  $k = n\omega/c$

$$\mathbf{E}(\omega) = \hat{\mathbf{E}}(\omega, z)e^{ikz}$$

- Assume envelope  $\hat{\mathbf{E}}(\omega, z)$  varies slowly in comparison to wavelength of light
  - same as paraxial wave equation (BPM)

$$\frac{d\hat{\mathbf{E}}}{dz} = -\frac{\alpha}{2}\hat{\mathbf{E}} + \frac{i\omega^2\mu_0}{2k}\mathbf{P}^{\text{NL}}e^{-ikz}$$

# Second-order nonlinearities

- No second-order nonlinearity in media with inversion symmetry
- Crystal symmetry in cubic semiconductors specifies that the only non-zero tensor elements are

$$\chi_{xyz}^{(2)} = \chi_{yzx}^{(2)} = \chi_{zxy}^{(2)}$$

- More independent tensor elements in heterostructures and at surfaces

# Pockels Electro-optic effect

- Pockels Electro-optic effect is  $0 + \omega \rightarrow \omega$  and appears as a modification to the refractive index
- transverse geometry, e.g. DC/RF field  $\perp$  surface  $\rightarrow$  phase modulation for TE optical polarisation
- conventionally use reduced  $r$  tensor notation so that optical path length change is

$$\Delta n L = \frac{n^3 r_{41} V L}{2d}$$

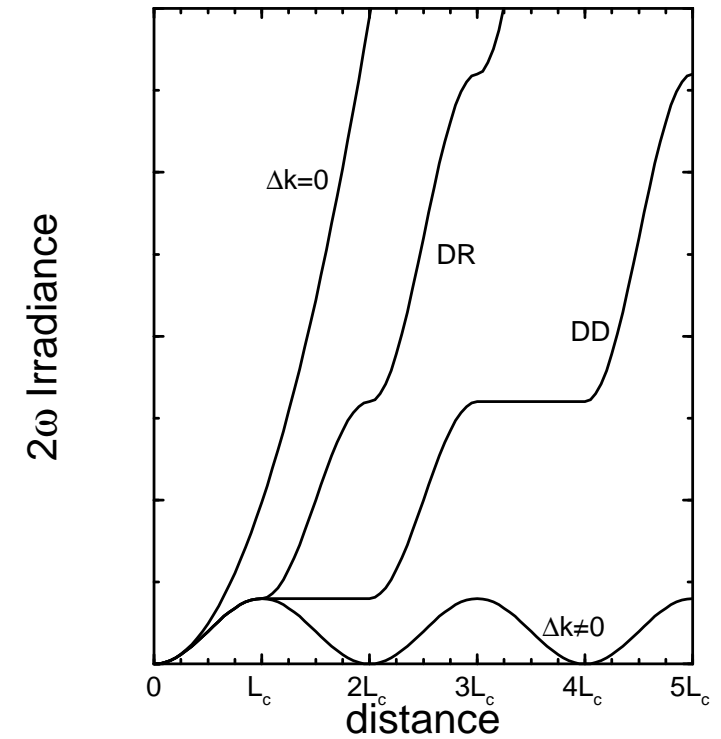
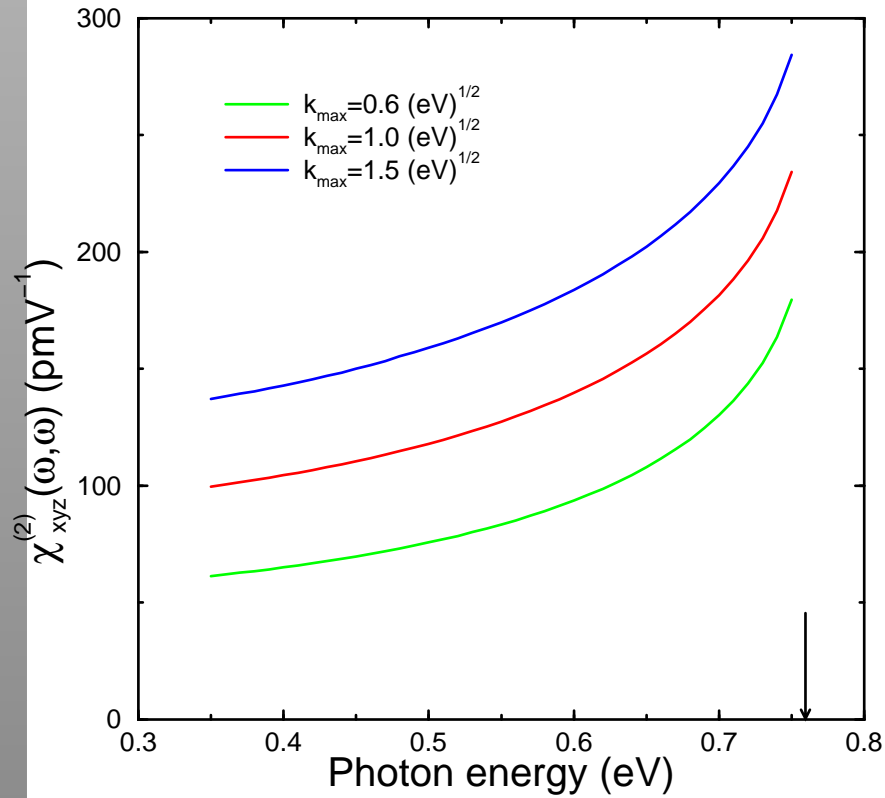
- GaAs at  $\lambda = 1.5 \mu\text{m}$ ,  $r_{41} = 1.36 \text{ pmV}^{-1}$  and  $n = 3.38$



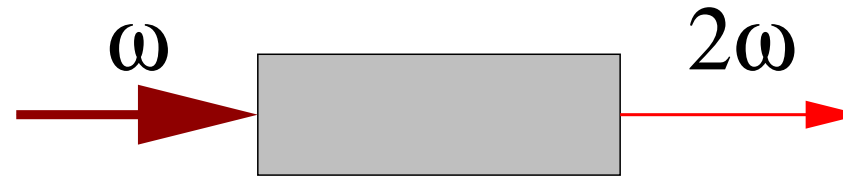
# Frequency conversion by $\chi^{(2)}$

- Optical frequency conversion (define  $\omega_3 = \omega_1 + \omega_2$ )
  - sum frequency generation:  $\omega_1 + \omega_2 \rightarrow \omega_3$
  - second-harmonic generation:  $\omega + \omega \rightarrow 2\omega$
  - difference frequency generation:  $\omega_3 - \omega_1 \rightarrow \omega_2$
  - parametric amplification:  $\omega_3 - \omega_1 \rightarrow$  **amplifies**  $\omega_1$
- reduced  $d$  tensor notation,  $d = \chi^{(2)}(\omega, \omega)/2$ .
- For epitaxial GaAs at  $\lambda = 4.1 \mu\text{m}$ ,  $d_{14} = 94 \text{ pmV}^{-1}$ .
- For continual forward energy conversion, require *Phase-matching*, i.e. phase velocities of generating and generated waves must be identical.

# Second harmonic generation

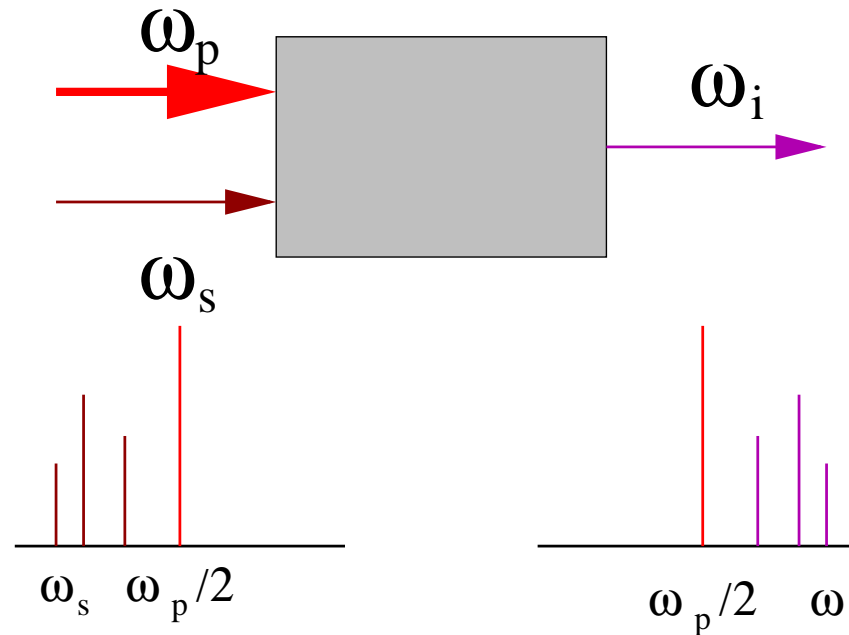


# Second harmonic generation



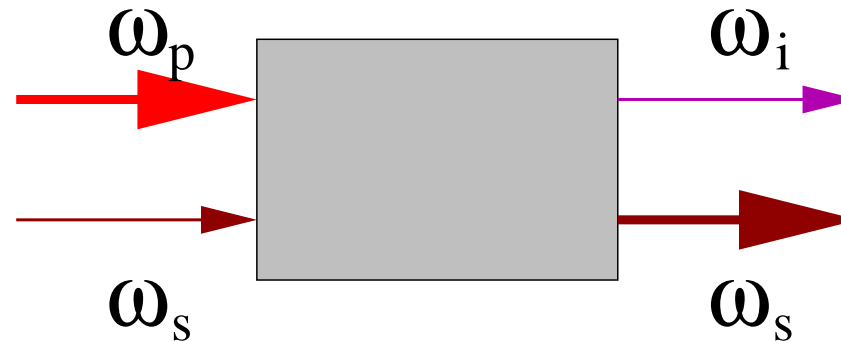
- Simplest setup to characterise nonlinear interaction
- type-I configuration: TE fundamental  $\rightarrow$  TM SH
- type-II configuration: TE and TM fundamental  $\rightarrow$  TE SH

# Difference Frequency Generation



- Channel conversion for WDM
- Potentially integrate pump laser on chip

# Parametric Amplification



- Broad-bandwidth amplifier
- Optical Parametric Oscillator for mid-IR — use cavity and  $\omega_s$  builds up from noise
- Potentially integrate resonator
- Potentially integrate pump laser on chip

# $\chi^{(3)}$ processes

- third-harmonic generation  $\propto \chi^{(3)}(\omega, \omega, \omega)$
- two-photon absorption  $\Delta\alpha = \beta I$

$$\beta(\omega) = \frac{3\omega}{2\varepsilon_0 n_0^2 c^2} \text{Im} \chi_{\text{eff}}^{(3)}(-\omega, \omega, \omega)$$

- nonlinear refraction  $\Delta n = n_2 I$

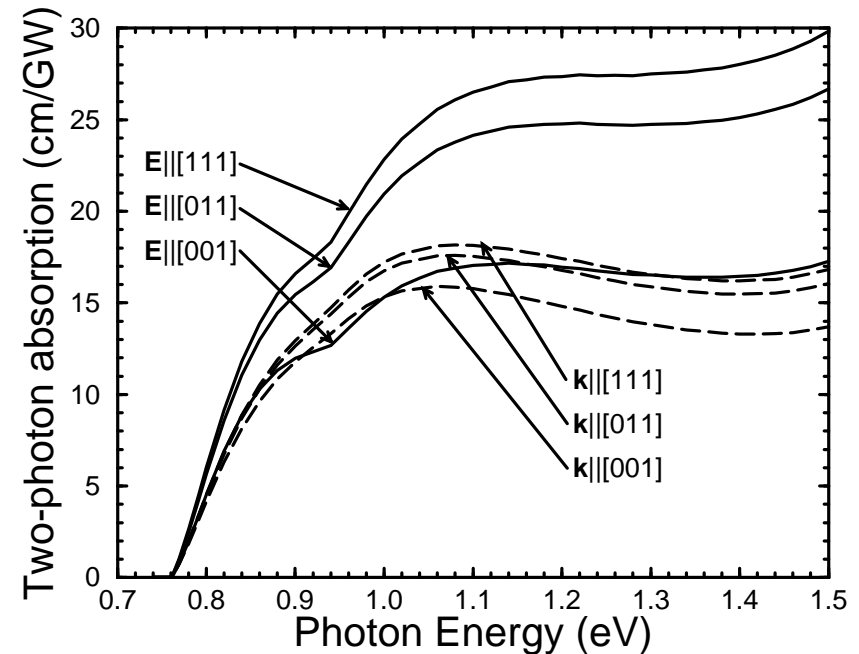
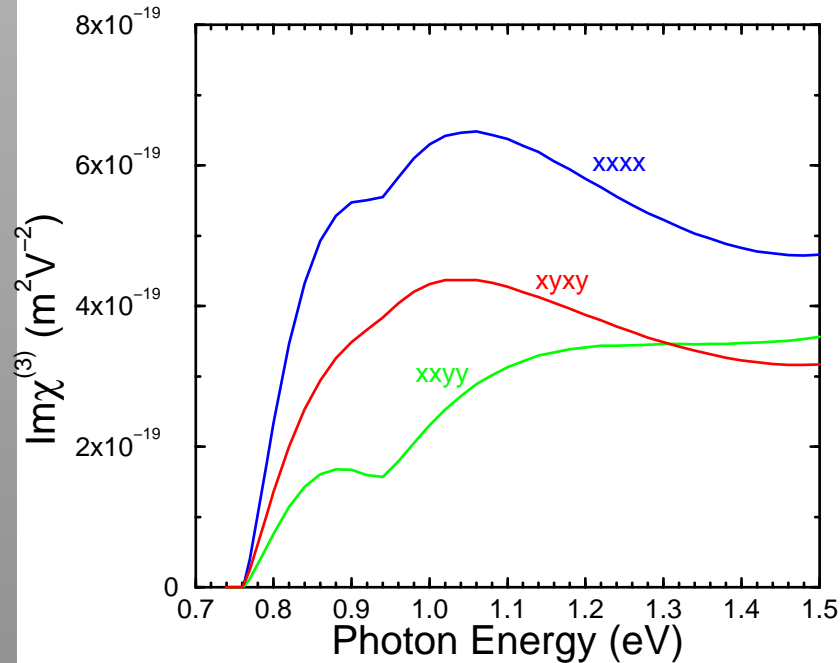
$$n_2(\omega) = \frac{3}{4\varepsilon_0 n_0^2 c} \text{Re} \chi_{\text{eff}}^{(3)}(-\omega, \omega, \omega)$$

- DC Kerr effect  $\propto \chi^{(3)}(0, 0, \omega)$

# $\chi^{(3)}$ *symmetry considerations*

- 4 independent nonzero tensor elements for bulk semiconductors
  - 3 for single  $\omega$   
 $\chi^{(3)}_{xxxx}(-\omega, \omega, \omega), \chi^{(3)}_{xyxy}(-\omega, \omega, \omega), \chi^{(3)}_{xxyy}(-\omega, \omega, \omega)$
- Three measurements required to completely characterise each nonlinear process
- Breaking symmetry, e.g. heterostructure introduces many more independent nonzero tensor elements

# Two-photon Absorption



- Calculated  $\text{Im}\chi^{(3)}$  tensor elements and spectra of  $\beta$  for GaAs.
- Scales as  $E_g^{-3}$ .



# Ultrafast Nonlinear Refraction

- Three measurements completely characterise nonlinear refraction in bulk (cubic) semiconductor

Strength	$n_2^L [001]$	$\Delta n / I _{[001]}$
Anisotropy	$\sigma$	$2 \{ n_2^L [001] - n_2^L [011] \} / n_2^L [001]$
Biref. param.	$\delta$	$\{ n_2^L [001] - n_2^C (\mathbf{k} \parallel [100]) \} / n_2^L [001]$

- $n_2$  scales as  $E_g^{-4}$
- For isotropic Kleinmann:  $\sigma = 0$ ,  $\delta = 1/3$
- GaAs at the half-gap (theory):  $\sigma = -0.82$ ,  $\delta = 0.08$
- AlGaAs at the half-gap (exper.):  $\sigma = -0.54$ ,  $\delta = 0.18$

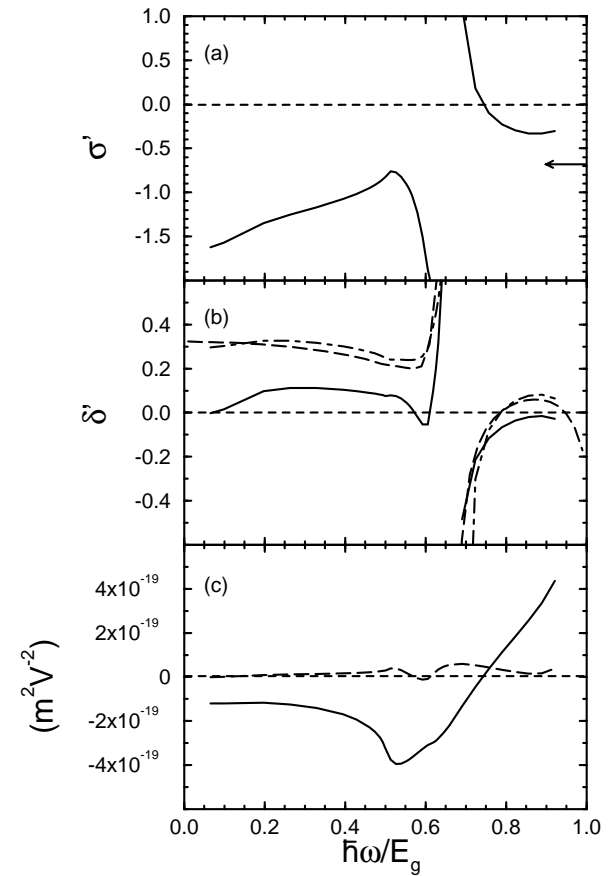
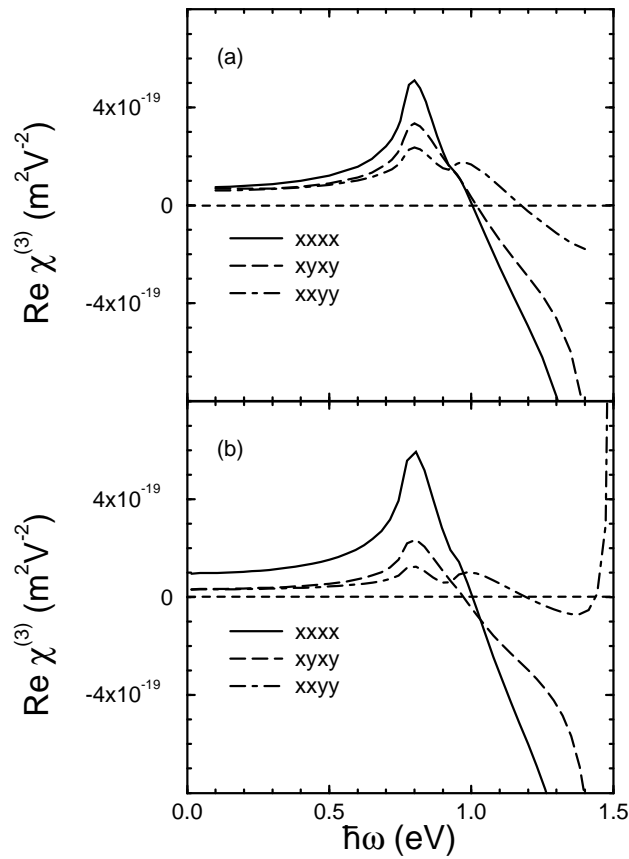
# Coupled Propagation Equations

- Usual configuration in semiconductor slab waveguides has  $TE_{\parallel}[110]$  (cleavage planes) and  $TM_{\parallel}[001]$ .

$$i \frac{\partial u}{\partial z} + \frac{\partial^2 u}{\partial x^2} + \gamma u + \left[ \left(1 - \frac{\sigma}{2}\right) uu^* + \left(1 - \delta - \frac{\sigma}{2}\right) vv^* \right] u + \left(\delta - \frac{\sigma}{2}\right) u^* v^2 = 0$$
$$i \frac{\partial v}{\partial z} + \frac{\partial^2 v}{\partial x^2} - \gamma v + \left[ \left(1 - \delta - \frac{\sigma}{2}\right) uu^* + vv^* \right] v + \left(\delta - \frac{\sigma}{2}\right) u^2 v^* = 0$$

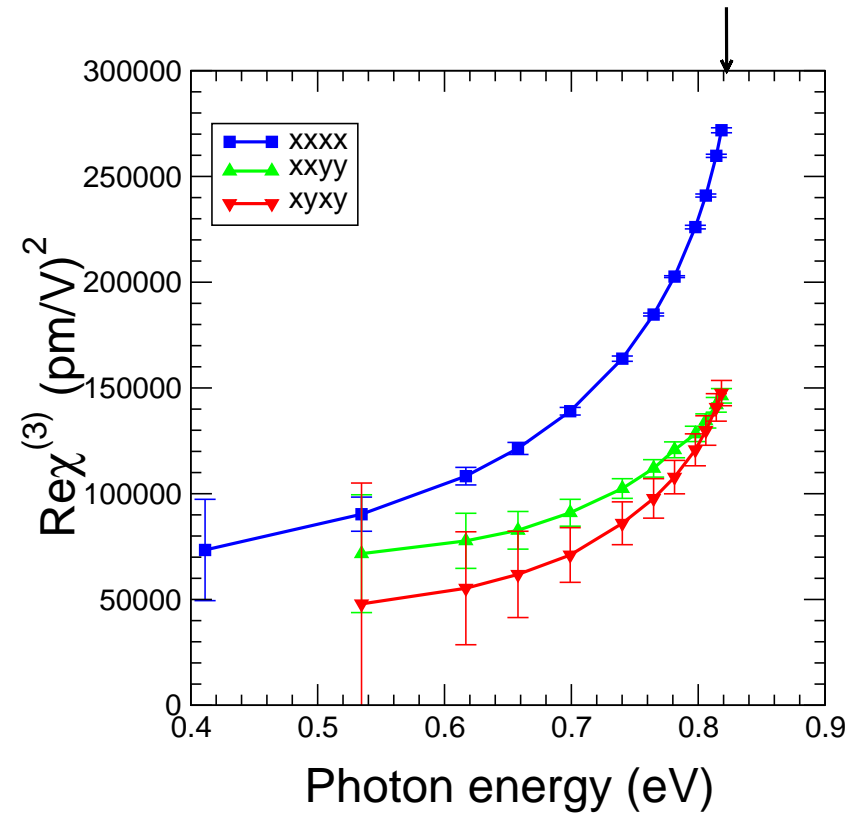
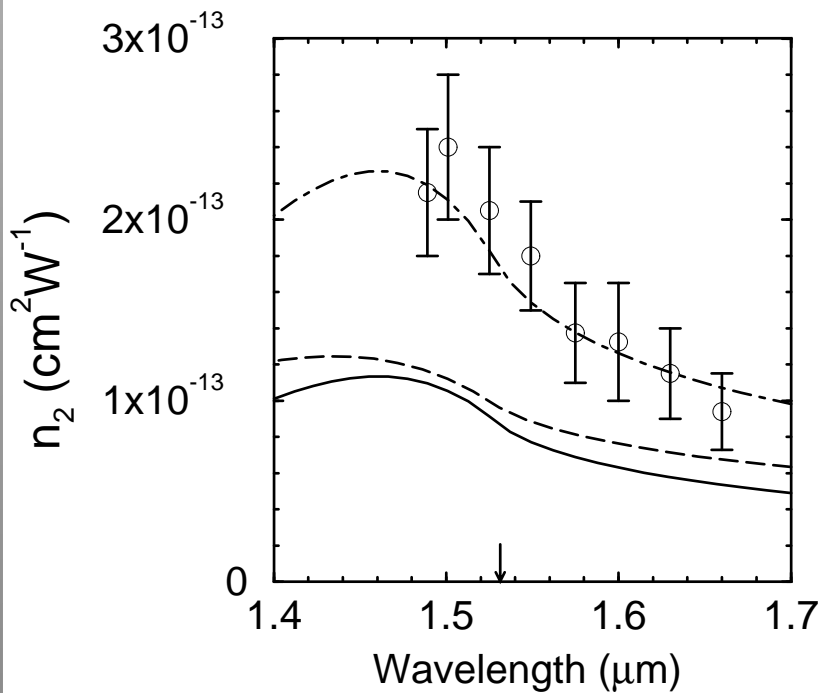
- $u$  and  $v$  are the scaled electric field amplitudes for TE and TM.
- $\gamma$  is proportional to the (structurally induced) birefringence  $n_{TM} - n_{TE}$ .

# Calculated $\chi^{(3)}$ in GaAs



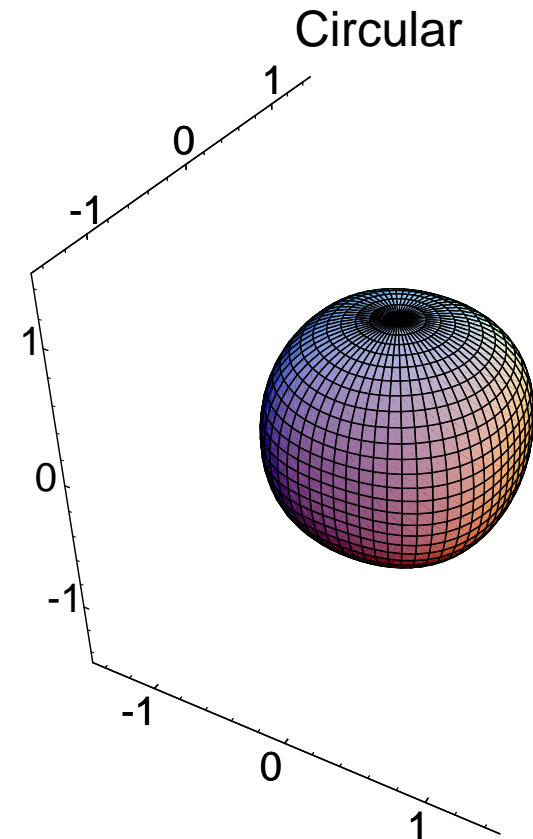
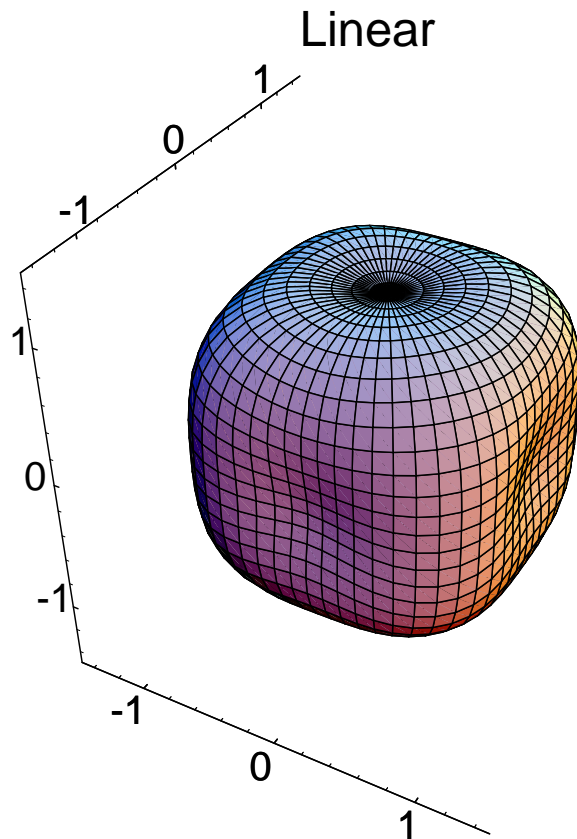
Top: 14-band, bottom: 8-band (isotropic)

# $n_2$ in $Al_{0.18}Ga_{0.82}As$



- Measured dispersion of  $n_2$  in  $Al_{0.18}Ga_{0.82}As$  and calculated  $Re\chi^{(3)}$  tensor components

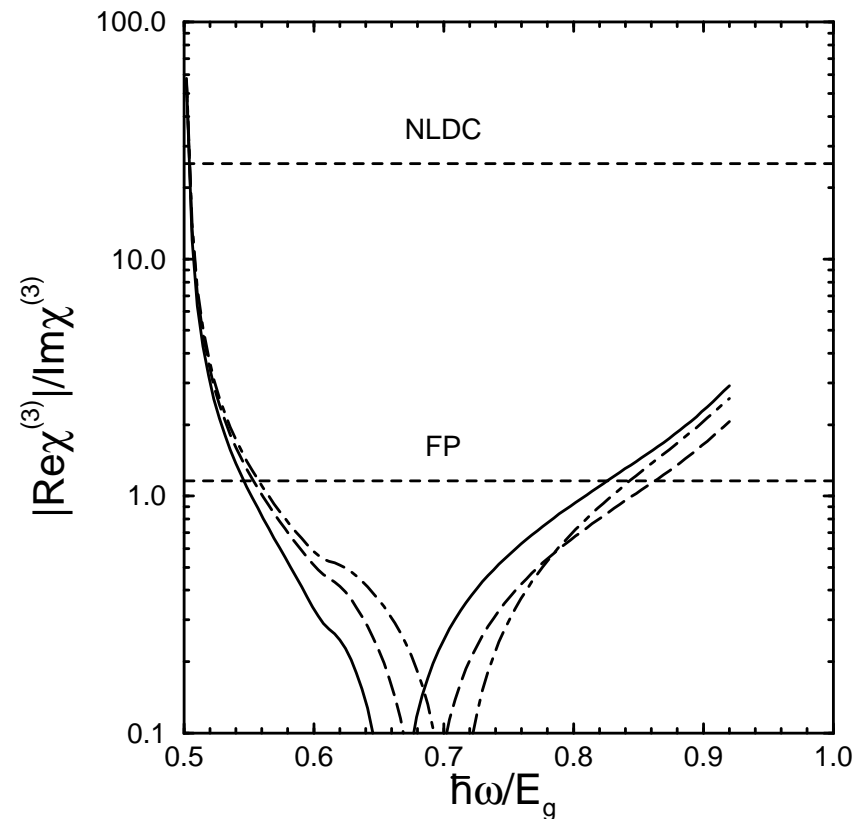
# $n_2$ in $\text{Al}_{0.18}\text{Ga}_{0.82}\text{As}$



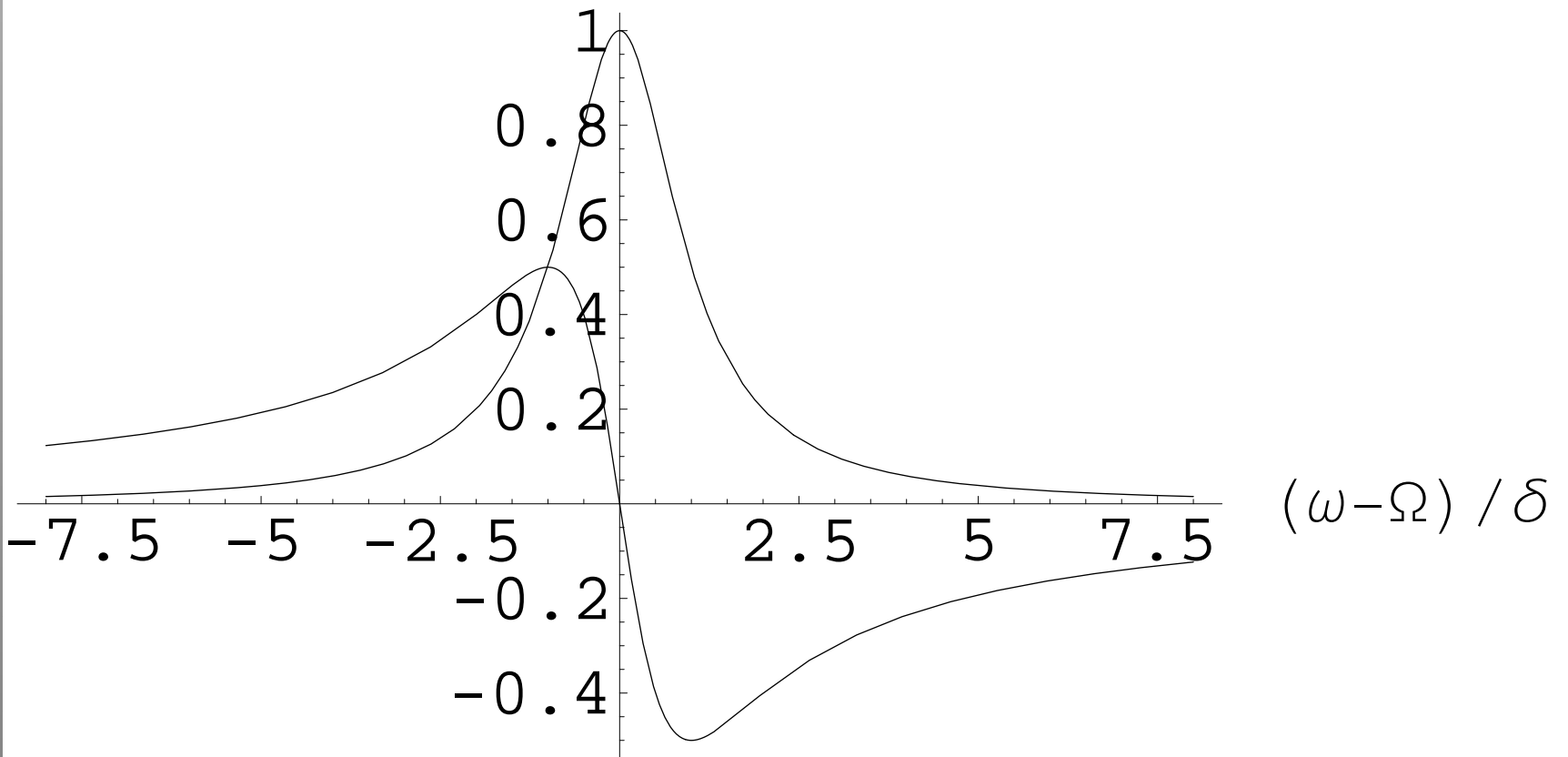
Deduced anisotropy from measurements of  $n_2$  in  
 $\text{Al}_{0.18}\text{Ga}_{0.82}\text{As}$  at  $\lambda = 1.55 \mu\text{m}$

# Figure-of-merit for NLR applications

- light absorbed in length  $\alpha^{-1}$
- phase change  $2\pi|\Delta n|L/\lambda \sim 2\pi$  for NLO applications
- therefore require figure-of-merit  $|\Delta n|/(\alpha\lambda) > 1$
- for  $\chi^{(3)}$  only, figure-of-merit  $|n_2|/(\beta\lambda) \propto |\text{Re}\chi^{(3)}|/\text{Im}\chi^{(3)}$



# Quasi- $\chi^{(3)}$ processes



# Carrier nonlinearities

- Free carrier absorption:  $N \uparrow, \alpha \uparrow$
- Absorption saturation (bandfilling) in passive device:  $N \uparrow, \alpha \downarrow, n \downarrow$
- Gain saturation in active device:  $N \downarrow, \text{gain} \downarrow, n \uparrow$
- Exciton absorption saturation (phase-space filling + screening):  $N \uparrow, \alpha \downarrow, n \downarrow$

N.B. effects on  $n$  are for below bandgap frequencies



## Example: bandfilling

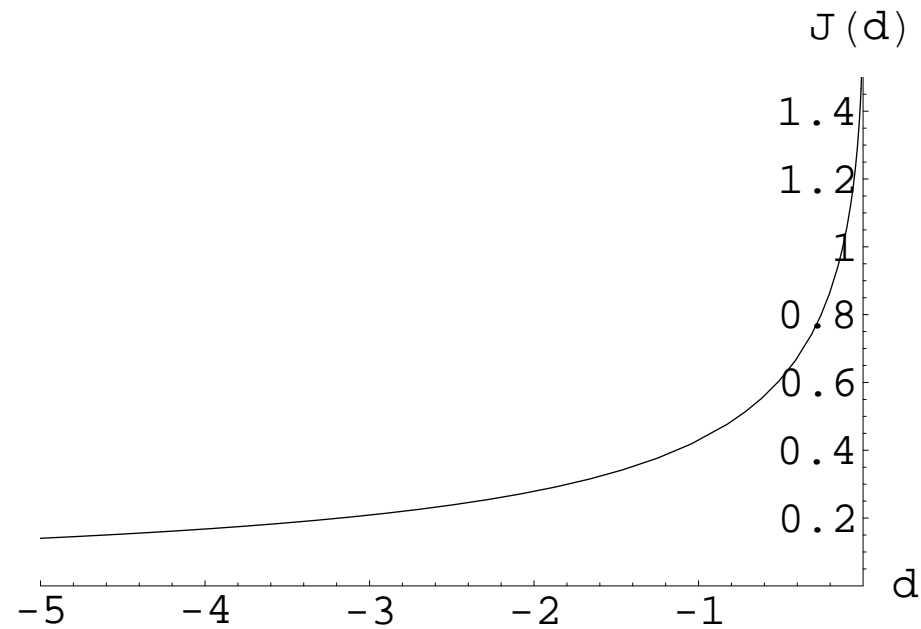
Assuming equal populations  $N$  of electrons and heavy-holes which have quasi-equilibrium Boltzmann thermal distribution, we get  $\Delta n = \sigma_n N$

$$\sigma_n(\omega) = -\frac{4\sqrt{\pi}}{n_0} \left| \frac{e\mathbf{p}_{vc}}{m_0\omega_g} \right|^2 \frac{1}{k_B T} \sum_{j=hh, lh} \frac{m_{rj}}{m_e} J \left( \frac{m_{rj}}{m_e} \frac{\hbar(\omega - \omega_g)}{k_B T} \right)$$

# Carrier nonlinearities

where

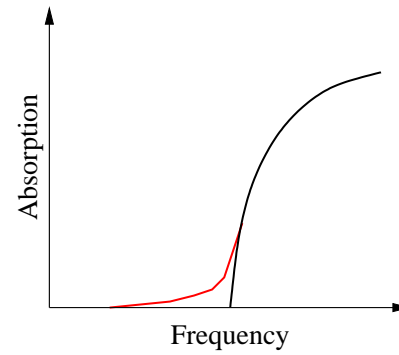
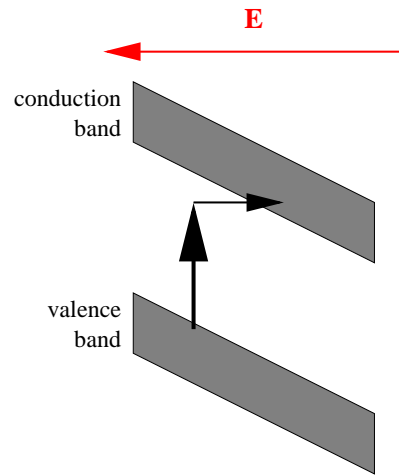
$$J(d) = \int_0^{\infty} \frac{\sqrt{x} e^{-x} dx}{x - d}$$



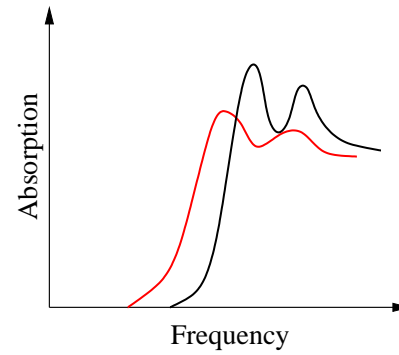
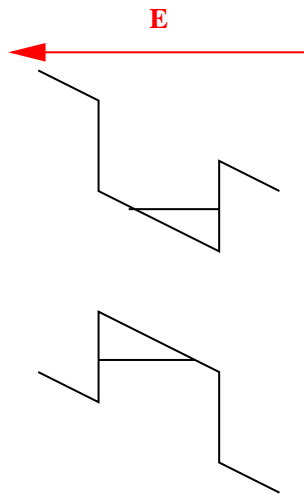
# ***DC Kerr effects***

- Franz-Keldysh effect: increases band-tail absorption
- Quantum Confined Stark Effect: shifts exciton resonances to longer wavelength
- Nonlinear absorption as excited carriers screen field (Self electro-optic effect device — SEED)

# DC Kerr effects



Franz-Keldysh



QCSE

# Thermal effects

- Absorbed light results in heating of medium and changes linear optical properties

$$\frac{\partial n}{\partial T} = \frac{\partial n}{\partial E_g} \frac{\partial E_g}{\partial T}$$

- For  $\text{Al}_x\text{Ga}_{1-x}\text{As}$

$$\partial E_g / \partial T = -(3.95 + 1.15x) \times 10^{-4} \text{ eVK}^{-1}.$$

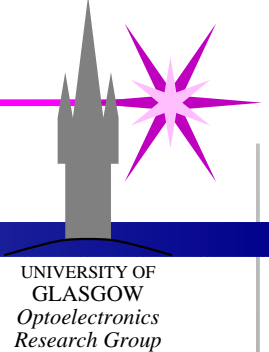
- Can differentiate Adachi formula for  $\partial n / \partial E_g$ 
  - $\partial n / \partial E_g < 0$  below bandgap
  - giving  $\partial n / \partial T > 0$  generally
  - e.g.  $6.5 \times 10^{-5} \text{ K}^{-1}$  in GaAs at  $1.5 \mu\text{m}$

# *Bibliography (materials)*



1. S. Adachi, "GaAs, AlAs and  $\text{Al}_x\text{Ga}_{1-x}\text{As}$ : Material parameters for use in research and device applications", J. Appl. Phys. **58**, R1 (1985).
2. "Properties of Gallium Arsenide", INSPEC (1990).
3. Ioffe Physico-Technical Institute Electronic Archive on Semiconductors  
<http://www.ioffe.rssi.ru/SVA/NSM/>
4. E. O. Kane, J. Phys. Chem. Solids **1**, 249 (1957).
5. P. Pfeffer & W. Zawadzki, "Conduction electrons in GaAs — 5-level k.p theory and polaron effects", Phys. Rev. B **41**, 1561 (1990).
6. G. Bastard, "Wave mechanics applied to semiconductor heterostructures" (Les Editions de Physique, 1989).

# Bibliography (NLO)



1. P. N. Butcher & D. Cotter, "The Elements of Nonlinear Optics" (Cambridge University Press, 1990).
2. Y. R. Shen, "The Principles of Nonlinear Optics" (Wiley, 1984).
3. A. Yariv, "Quantum Electronics" (Wiley, 1989).
4. D. C. Hutchings, "Applied Nonlinear Optics",  
<http://userweb.elec.gla.ac.uk/d/dch/course.pdf>
5. D. C. Hutchings, *et al*, "Kramers-Krönig relations in nonlinear optics", *Opt. and Quant. Electr.* **24**, 1 (1992).
6. D. C. Hutchings & B. S. Wherrett, "Theory of Anisotropy of Two-Photon Absorption in Zinc-Blende Semiconductors", *Phys. Rev. B* **49**, 2418 (1994).
7. D. C. Hutchings & B. S. Wherrett, "Theory of the Anisotropy of Ultrafast Nonlinear Refraction in Zinc-Blende Semiconductors", *Phys. Rev. B* **52**, 8150 (1995).
8. J. S. Aitchison, *et al*, "The Nonlinear Optical Properties of AlGaAs at the Half-Band-Gap", *IEEE J. Quantum Electron.* **33**, 341 (1997).